



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 16, 2026

IGI Report Number

LG765639239

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

6.51 - 6.57 X 4.04 MM

GRADING RESULTS

Carat Weight

1.07 CARAT

Color Grade

E

Clarity Grade

VS 1

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

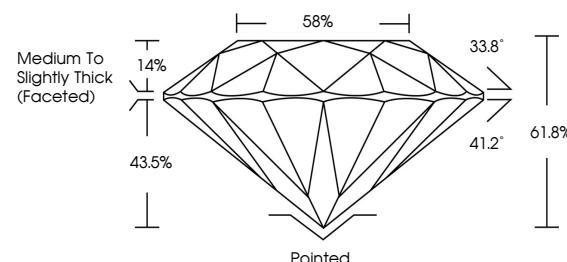
IGI LG765639239

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

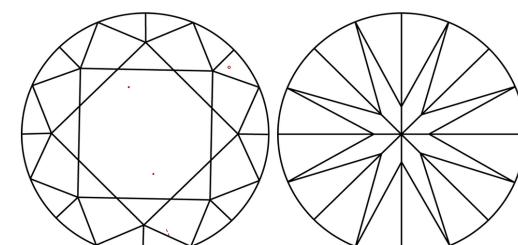
Type Ila

LG765639239
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

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January 16, 2026	IGI Report No LG765639239	ROUND BRILLIANT	1.07 CARAT	E
Color Grade	Color Grade	VS 1	IDEAL	
Clarity Grade	Clarity Grade	VS 1	IDEAL	
Cut Grade	Cut Grade	VS 1	IDEAL	
Depth	Depth	VS 1	IDEAL	
Table	Table	VS 1	IDEAL	
Girdle	Girdle	VS 1	IDEAL	
Polish	Polish	VS 1	IDEAL	
Symmetry	Symmetry	VS 1	IDEAL	
Fluorescence	Fluorescence	VS 1	IDEAL	
Inscription(s)	Inscription(s)	VS 1	IDEAL	

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Carat Weight 1.07 CARAT

Color Grade E

Clarity Grade VS 1

Cut Grade IDEAL

Depth

Table

Girdle

Polish

Symmetry

Fluorescence

Inscription(s)

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Type Ila

ADDITIONAL GRADING INFORMATION

Polish EXCELLENT

Symmetry EXCELLENT

Fluorescence NONE

Inscription(s) LGI LG765639239

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IGI